



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF  
PATENT  
1763

In re Application of:

Kuthi, et al.

Application No: 09/611,037

Filed: July 6, 2000

For: METHOD FOR MAKING A  
SEMICONDUCTOR PROCESS  
CHAMBER ELECTRODE

) Docket No: LAM1P077A

)

) Group Art Unit: 1763

) Examiner: Alejandro, L.

) Date: September 24, 2002

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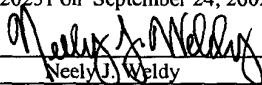
TC 1700

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Commissioner for Patents  
Washington, DC 20231

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on September 24, 2002.

Signed:   
Neely J. Wohld

Sir:

Transmitted herewith is a proposed amendment in the above-identified application.

The fee has been calculated as shown below.

Claims

	Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	08	-	20	0	X09 = \$	OR X18 = \$
INDEP CLAIMS	01	-	03	0	X42 = \$	OR X84 = \$
[ ] Multiple Dependent Claim Present and Fee Not Previously Paid				\$140	\$280	
				TOTAL	\$_____	\$____0

- Applicant hereby petition for a \_\_\_\_\_ month extension of time to respond to the outstanding Office Action.
- Applicant believes that no Extension of Time is required; however, if it is determined that such an extension is required, Applicant hereby petitions that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805
- Enclosed is our Check No. \_\_\_\_\_ in the amount of \$\_\_\_\_\_ to cover the extension of time fee.
- If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P077A). A copy of this sheet is enclosed.

Respectfully submitted,  
MARTINE & PENILLA, LLP

  
Rick von Wohld, Esq.  
Reg. No. 48,018



PATENT

## In the United States Patent and Trademark Office

Applicant: Kuthi et al. )  
Applicant's Reference: LAM1P077A ) Examiner: Alejandro, L.  
Application No: 09/611,037 ) Art Unit: 1763  
Filed: July 6, 2000 ) Date: September 24, 2002  
For: METHOD FOR MAKING A SEMICONDUCTOR )  
PROCESS CHAMBER ELECTRODE )

#9  
10/4/02  
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Signed: Neely J. Welsky  
Neely J. Welsky

## Separate Letter to the Official Draftsperson

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Enclosed herewith are the nine (9) sheets of Formal Drawings (Figs. 1A, 1B, 1C, 1D, 1E, 2A, 2B, 2C, 2D, 2E, 3, 4A, 4B, and 5) for the above-referenced case. If the draftsperson has any questions concerning these drawings, please contact the undersigned at the number set forth below.

Applicant believes that no fees are due in connection with the filing of the Formal Drawings. However, if it is determined that any fees are due in connection with the filing of these drawings, the Commissioner is authorized to charge such fees to deposit account 50-0805 (Order No LAM1P077A).

Respectfully submitted,  
MARTINE & PENILLA, LLP

Rick von Wohld, Esq.  
Reg. No. 48,018

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Attorney Docket No: LAM1P077A